

PATENT
452080-2010.2

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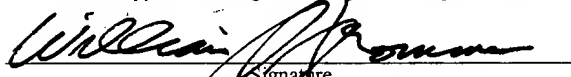
Applicant(s) : Hans MEILING et al. Notice of Allowance
Dated: January 8, 2004
Serial No. : 09/852,999 Confirmation No.: 5824
For : SEMICONDUCTING DEVICES AND METHOD OF
MAKING THEREOF
Filed : May 10, 2001
Examiner : Shrinivas H. Rao
Art Unit : 2814

745 Fifth Avenue
New York, NY 10151

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Issue Fee Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 29, 2004.

William S. Frommer, Reg. No. 25,506

Name of Applicant, Assignee or Registered Representative


Signature
January 29, 2004

Date of Signature

FILING OF FORMAL DRAWINGS

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Commissioner for Patents
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Attention: **Official Draftsperson**

Sir:

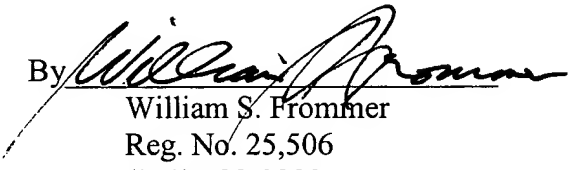
In accordance with the requirement cited in the Notice of Allowability (PTOL-37, Paper No. 7), Applicants file herewith (3) sheets of formal drawings to be made of record in the

present application in place of the original drawings and which avoid the objections stated in
PTO Form 948 attached to Paper No. 11.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP
Attorneys for Applicants

By



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Encs. - Formal Drawings (3) Sheets